

Scintillating sensors based on InAs quantum dots in a GaAs semiconductor matrix

Snowmass'2021 white paper planning

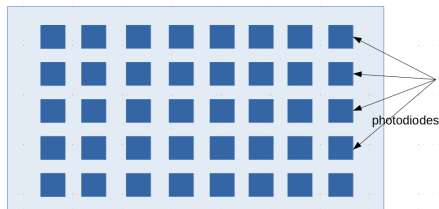
P.Murat (Fermilab)

May 08 2020

Motivation

- Next generation trackers will require timing resolution ~ 5 ps
- solid state detectors based on collecting drifting electrons may have a “floor” above that. For example, LGAD's seem to have a floor at a level of 15 ps
- scintillating sensors:
 - ▶ collect photons, not drifting electrons - the detector could be much faster
 - ▶ SciFi trackers are know, but fibers have too long travel time, too much material
 - ▶ **focus on planar sensors**
- the scintillator would need to have very high light yield, fast emission
- semiconductor-based scintillators ? $N_{ph}/MeV \sim 1e6/1.8 \cdot E_{gap} \sim (2 - 2.5)10^5$
- people:
 - ▶ Fermilab: C.Gingu, S.Los, P.Murat
 - ▶ SUNY Poly : S.Oktyabrsky, M.Yakimov, V.Tokranov, K.Dropiewsky, A.Minns

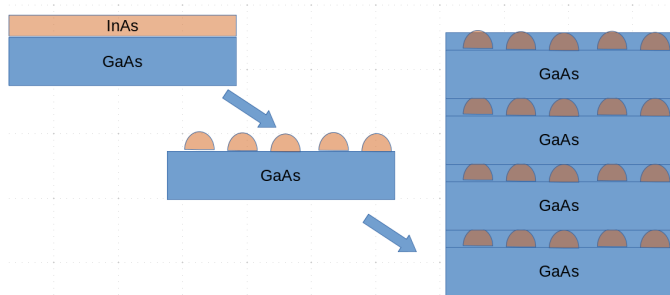
Concept of a tracking sensor: GaAs/QD sensor with PD's as pixels



- sensors : thin wafers with integrated photodetectors
- detect light, light propagates in all directions - could expect high “fill factor”
- not a sensor for vertex detectors
 - ▶ coordinate resolution: 500 um pad $\Rightarrow \sigma \sim 150\mu$ - adequate for many trackers
- material budget: 20 um GaAs \sim 40 um Si \Rightarrow 3800 $e^- h$ pairs
 - ▶ **need to read out signals corresponding to 1000 photons**
- currently, measure signals with the leading edge of \sim 150-200 ps
 - ▶ detected photons travel distances \sim 1 mm, no \sim 10-15 ps theoretical floor

How to make a sensor with embedded QDs ?

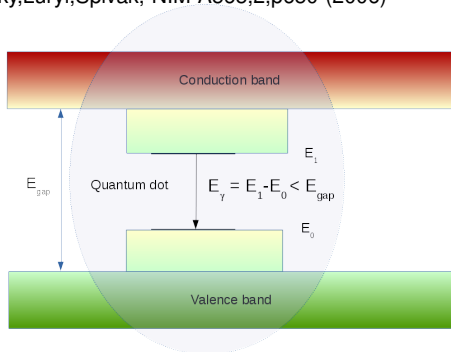
- the answer: InAs/GaAs self-assembling quantum dots
 - ▶ produced using molecular beam deposition in vacuum (MBE) at several hundred C
- lattice constants of GaAs and InAs are different
- minimization of the strain energy leads to stable nm-scale stable InAs islands - QD's
- repetitive procedure leads to a multi-layer structure



N.B. InAs/GaAs structures are grown as thin , tens of microns, wafers (i.e, 3 inch)

How to make sensor transparent to the QD emission

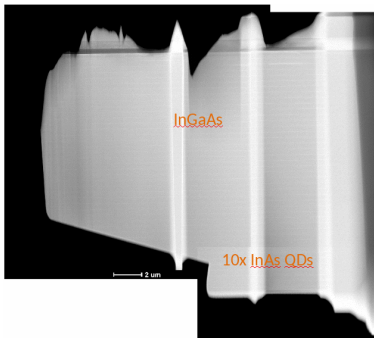
Kastalsky,Luryi,Spivak, NIM A565,2,p650 (2006)



- condition satisfied if QD's are embedded into a semiconductor bulk with $E_{gap} > E_\gamma$
 - ▶ InAs QD's: $E_\gamma \sim 1.08$ eV, $E_{gap}^{GaAs} = 1.4$ eV
- other material choices possible, however much less investigated
- **light yield $\sim 240,000$ photons/MeV, emission time $\tau \sim 1$ ns**

N1801 20um Scintillator: low-mag. STEM

114012 HAADF



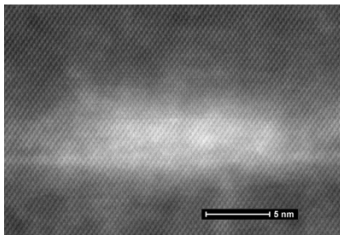
| |
|---|
| 200nm p-In _{0.35} GaAs |
| 200nm p-In _{0.35} GaAs |
| 700nm i-In _{0.35} GaAs 450C |
| 0.2μm n-In _{0.35} GaAs |
| 0.1μm n+In _{0.35} GaAs 450C |
| 0.8μm var-buf 350C n+Al _{0.92-0.6} In _{0.02-0.35} Ga _{0.05} As |
| 0.1μm i-Al _{0.9} Ga _{0.06} In _{0.04} As 350C |
| 0.4μm n-n+GaAs 500C (var.) |
| 0.15μm vary-Al _{0.3-0.7} GaAs 565C |
| 10nm p(1e17cm ⁻³)GaAs 595C |
| 195nm i-GaAs 595C (var.) |
| 2ML i-AlAs 515C |
| 2ML i-InAs QDs 515C |
| 100nm i-GaAs 595C (var.) |
| 95nm i-GaAs 595C |
| 10nm p(1e17cm ⁻³)GaAs 595C |
| 195nm i-GaAs 595C (var.) |
| 2ML i-AlAs 515C |
| 2ML i-InAs QDs 515C |
| 100nm i-GaAs 595C (var.) |
| 0.15μm vary-Al _{0.3-0.7} GaAs 565C |
| 0.15μm i-GaAs 565C |
| 0.1μm i-AlAs 565C |
| 0.3μm i-GaAs buffer 615C |
| i-GaAs, SI 3" |

} 49x
19.6μm

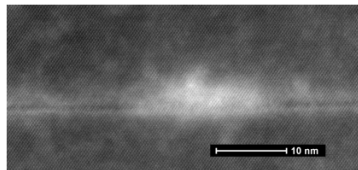
- sensors production, optical and electrical characterization at SUNY Poly
 - ▶ high-vacuum MBE, ~ 3" wafers
- InGaAs photodiode - integrated, processed on a sensor
- wafer with codename N1801 : 50 layers of InAs QD's separated by 0.4 um of GaAs

N1801 20um Scintillator: QDs, TEM, DF

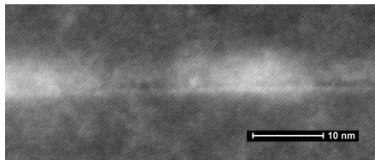
#120498HAADF



#120554-HAADF



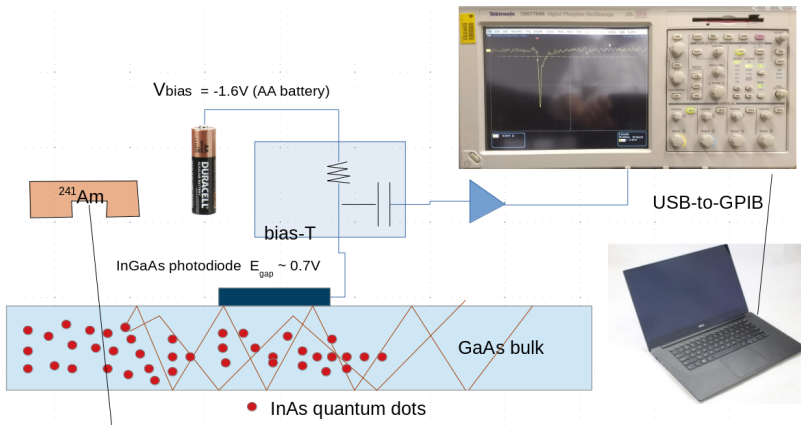
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QD diam ~ 14nm

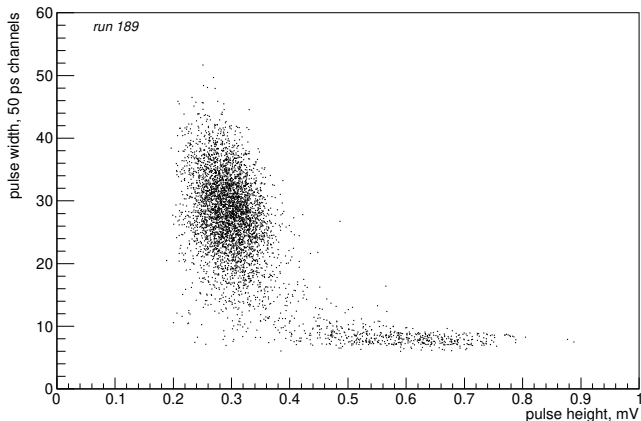
QD density $(4-5) \times 10^{10} \text{ cm}^{-2}$

Measurements at Fermilab



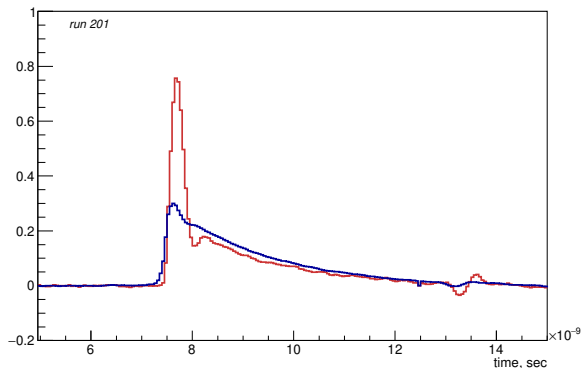
- measurements : use a probe station in WH14 clean room
- amplifiers - 1-3 stages, the total gain up to 600
- use TDS7704B (7GHz, 20Gs) as a trigger+DAQ
- read the oscilloscope over GPIB (readout rate up to a few Hz), analyze data offline

First data : waveform analysis



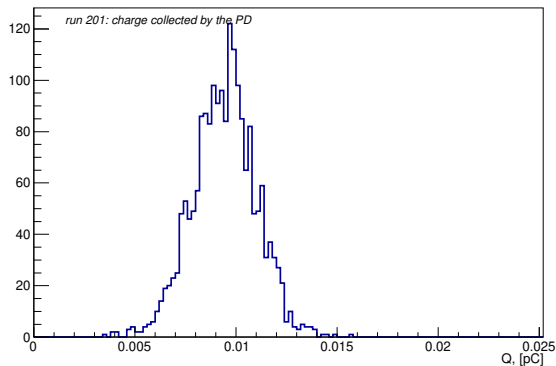
- for each waveform, reconstruct the pulse height and the pulse width (FWHM)
- observe two distinct groups of signals
- the effect is robust, observed with different sensors, different photodiodes, and different amplifiers

Comparison of the averaged waveforms



- charge in the spike consistent with the direct ionization in the 50x500x0.7 μm PD
- current interpretation:
 - ▶ pulses with spikes - α 's going through the PD and stopping in the scintillator
 - ▶ pulses without spikes - particles hitting the scintillator, but not the PD
- tail consistent with the QD radiative lifetime of $\sim 1\text{-}1.5$ ns

Energy resolution for Am-241 5.5 MeV α -particles

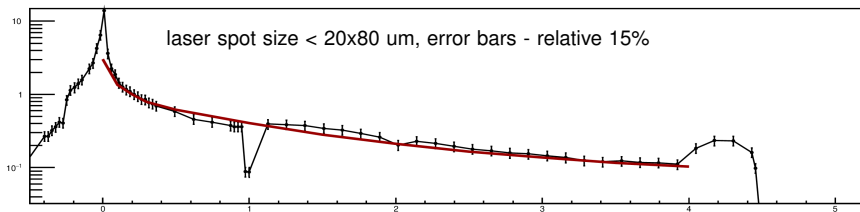


- energy of the particle entering the detector ~ 4.6 - 4.7 MeV (losses in the source)
- charge on PD ~ 0.01 pC - corresponds to the light collection efficiency of $\sim 6\%$
- observed energy resolution ~ 10 - 15% , expected much better even for 6% efficiency
- tested sensors are long and thin - light is waveguided to the PD, reflects multiple times
- multiple reflections in the sensor?

Laser scan of the sensor: measure the PD photocurrent

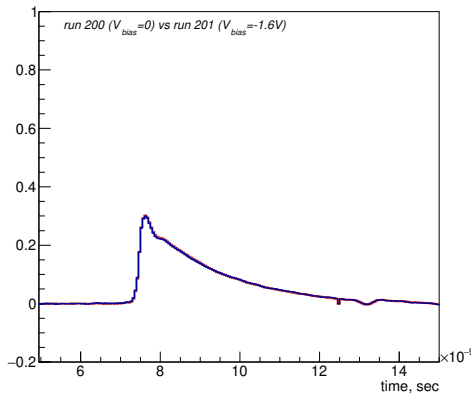
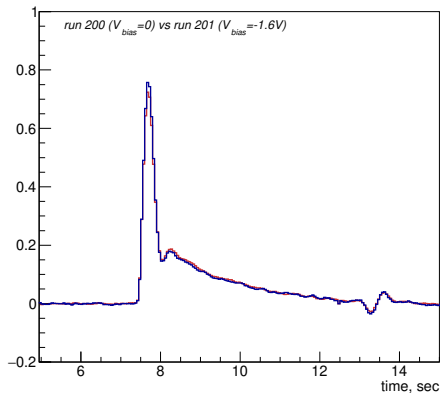


Graph



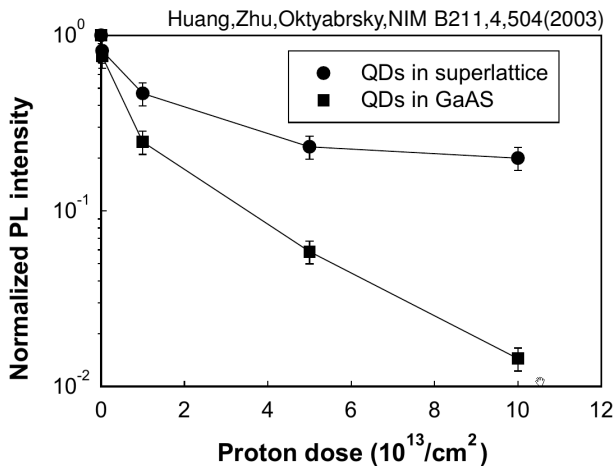
- laser scan (beam size $70 \times 20 \mu\text{m}^2$) captures the structure of the photodiode, defects, epoxy at the end
- MC with $\lambda_{\text{abs}} \sim 2.2 \text{ mm}$ and probability of diffuse reflection of 2.5% gives good description
- geometry is important: **1 mm away from the PD the signal drops by $\sim \times 10$**
- **photodiodes on Gen1 detectors are too small for efficient light detection**

PD's can operate with zero external bias



- plotted: overlaid average waveforms for two runs - with $V_{bias} = -1.6V$ and with $V_{bias} = 0$
- detector can operate without an external bias voltage (photovoltaic mode, as a solar cell)
- a p-n junction has an internal bias of the order of 1V (0.7 for Si),
 - ▶ external bias of $\sim 1V$ doesn't add much
- zero-bias mode minimizes the dark current: no shot noise

Radiation hardness - irradiation with 1 MeV protons



- emission of InAs QD's in a 5-layer superlattice reduced by 20% after 10¹³ protons/cm²
- 99% recovery after 5 · 10¹³ p/cm² (~ 90 MRad) and 10 min annealing in N₂ at 600 deg C
- Mu2e-II: expect ~ 10¹² protons / cm²

- Optical Properties of InAs Quantum Dots/GaAs Waveguides for Ultra-fast Scintillators, K.Dropiewski et al, Journal of Luminiscence, 220 (2020) 116952
- Scintillation detector based on InAs quantum dots in a GaAs semiconductor matrix for charged particle tracking, P.Murat et al, CPAD'2019, Madison

Summary

- first set of measurements with the QD/GaAs-based scintillating detectors completed
- observed that detectors can operate in a photovoltaic mode

Next steps

- study of the sensor response as a function of deposited energy
- optimization of the detector geometry (larger PD's)
- study of detectors with multiple PD's
- development of the readout electronics
- temperature dependence of sensor response